

## EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	"20020039835".pn.	US-PGPUB; USPAT	OR	ON	2006/03/20 08:34
L2	2810	hot adj wall	US-PGPUB; USPAT	OR	ON	2006/03/20 08:34
L3	1	1 and L2	US-PGPUB; USPAT	OR	ON	2006/03/20 09:14
L4	1	"20040182309".pn.	US-PGPUB; USPAT	OR	ON	2006/03/20 08:36
L5	1	L4 and "500"	US-PGPUB; USPAT	OR	ON	2006/03/20 08:49
L6	1	2 and l4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:38
L7	0	variation and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:38
L8	1	thickness and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:39
L9	1	"2" and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:44
L10	1	temperature and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:45
L11	1	sccm and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:49
L12	1	inert and 11	US-PGPUB; USPAT	OR	ON	2006/03/20 08:51
L13	1	torr and 4	US-PGPUB; USPAT	OR	ON	2006/03/20 08:51
L14	1	single and 1	US-PGPUB; USPAT	OR	ON	2006/03/20 08:59
L15	1	deposition adj rate and 1	US-PGPUB; USPAT	OR	ON	2006/03/20 09:02
L16	0	heat\$3 and 1	US-PGPUB; USPAT	OR	ON	2006/03/20 09:02
L17	1	"5939333".pn.	US-PGPUB; USPAT	OR	ON	2006/03/20 09:20
L18	1	single and 17	US-PGPUB; USPAT	OR	ON	2006/03/20 09:23
L19	1	2 and 17	US-PGPUB; USPAT	OR	ON	2006/03/20 09:23
S1	1	"20040182309".pn.	US-PGPUB; USPAT	OR	ON	2006/03/19 20:39
S2	1	single and S1	US-PGPUB; USPAT	OR	ON	2006/03/19 20:40

## EAST Search History

S3	1	rapid and S1	US-PGPUB; USPAT	OR	ON	2006/03/19 20:39
S4	1	elements and S1	US-PGPUB; USPAT	OR	ON	2006/03/19 20:40
S5	1	energy and S1	US-PGPUB; USPAT	OR	ON	2006/03/19 20:42
S6	12708	single adj wafer	US-PGPUB; USPAT	OR	ON	2006/03/19 20:42
S7	2810	hot adj wall	US-PGPUB; USPAT	OR	ON	2006/03/19 20:42
S8	175484	cvd or vapor adj deposition	US-PGPUB; USPAT	OR	ON	2006/03/19 20:43
S9	175245	silicon near3 (film or layer or coating)	US-PGPUB; USPAT	OR	ON	2006/03/19 20:43
S10	224	S6 and S7 and S8 and S9	US-PGPUB; USPAT	OR	ON	2006/03/19 20:43
S11	783	rapid near2 S8	US-PGPUB; USPAT	OR	ON	2006/03/19 20:44
S12	18	S10 and S11	US-PGPUB; USPAT	OR	ON	2006/03/20 08:34